

Resource Summary Report

Generated by PRECISE-TBI on Jul 30, 2026

Gatan: Murano In-Situ Stages Scanning Electron Microscope (SEM) Specimen Stages

RRID:SCR_019936

Type: Tool

Proper Citation

Gatan: Murano In-Situ Stages Scanning Electron Microscope (SEM) Specimen Stages (RRID:SCR_019936)

Resource Information

URL: <https://www.gatan.com/products/sem-specimen-stages/murano-situ-stages>

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Description: SEM specimen heating stage that is specifically designed to enable in-situ research and designed to be compatible with geometrical requirements of different detectors including electron backscatter diffraction (EBSD) for dynamic observations.

Resource Type: instrument resource

Keywords: Gatan, SEM Specimen Stages, Instrument Equipment, USEDit,

Availability: Commercially available

Resource Name: Gatan: Murano In-Situ Stages Scanning Electron Microscope (SEM) Specimen Stages

Resource ID: SCR_019936

Alternate IDs: Model_Number_Murano

Record Creation Time: 20220129T080347+0000

Record Last Update: 20260725T190919+0000

Ratings and Alerts

No rating or validation information has been found for Gatan: Murano In-Situ Stages Scanning Electron Microscope (SEM) Specimen Stages.

No alerts have been found for Gatan: Murano In-Situ Stages Scanning Electron Microscope (SEM) Specimen Stages.

Data and Source Information

Source: [SciCrunch Registry](#)

Usage and Citation Metrics

We have not found any literature mentions for this resource.